PF/KEKB入射器の熱電子銃とバンチング

2018/10/18

大澤 哲

KEKB当時のA1ユニットの構成



KEKB当時の入射部の様子

バンチャ部



A1ユニット全景



電子銃&高圧ステーション



エネルギー分析系とOTRモニター



電子銃&グリッド・パルサー(2台)



陰極部(Y-796)



短パルスビームのバンチングの様子



SHB1 of 114MHz





Input coupler





Monitor Coupler

Beam induced field in SHB1

114MHz RF & induced fields by a single pulse beam of 10nC are shown

(1) just after the beam passed

(2) after 96.2ns.



Field attenuation is not sufficient

03 Oct 2000 16:00

Histogram

Time: 2.000 ns/div Delay: 156.030 ns

Trigger Level: -400 mV

SHB2 of 571MHz



SHB2 Cavity

Monitor Coupler

Input coupler

Prebuncher and buncher of pre-injector A







Simulation by PARMELA

Gun	200 kV
SHB	476 MHz
PB1	2856 MHz
PB2	2856 MHz
Buncher	2856 MHz





NEW INJECTOR FOR 200KEV. 3.0A, 6MV/m, 540DEG.

200kV, 3A, 1 ns

An example of PARMELA



200 kV, 3A, 2 ns



An example of PARMELA



An example of PARMELA

ストリークカメラを用いたバンチング手順の具体例

Bunch structure measured with a streak camera



Single bunch procedure

- 1. Turn off SHB1&2 power source, or delay rf pulse timings not to affect the beam.
- 2. Adjust the beam timing by changing the time delay of a grid pulser so that the central bunch peak becomes maximum.
- 3. Turn on only the SHB1 power source, or return the rf timing for modulating the beam.
- 4. Adjust the SHB1-rf phase so that the center bunch becomes the highest peak and maximum.
- 5. Turn on the SHB2-rf power source, or return the rf timing for modulating the beam.
- 6. Adjust the SHB1-rf phase so that the center bunch becomes maximum and satellite bunches become minimum.

Positron Linac/BT Orbit



positron production target

The 10-nC electron/positron beams accelerated in the KEKB linac

RF-gunとそのバックアップ

KEKB当時のA1 unit

Bunching System





熱電子銃&高圧ステーション





SKBに向けた二階建て改造直前のA1 unit



A1ユニットの再構成 (2015年3月)

開発中のRF Gunのバックアップとして、 熱陰極電子銃の入射部を二階部分に上げ、SKBのフェイズ1に備える。

加速管グループと電子銃グループを中心に、目下工事中。(2015年3月)



AT unit layout







現在のA1 unit

Bunching System





熱電子銃





PB+B+Acc1,2 power-phase tuning



KEK当時の各種装置の許容度と設計値

Tolerance of the Pre-injector Parameter

Instruments	Tolerance range	
Gun beam timing	±45 ps	
Gun high voltage	±0.38 %	
SHB1phase	±1.1 deg	
SHB2 phase	±1.3 deg	
Buncher phase	±1.7 deg	

- The e^+/e^- beam is a single bunch of which width in 10ps (FWHM).
- The each tolerance range is defined so that when each instrument changes the transmission rate of the primary electron beam intensity maintains more than 90% of the maximum value at the positron production target.



Gun parameters

Beam current	$0 \sim 15 \mathrm{A}$	Heater power	40 W
Grid pulse	-300 ~ -700 V	Cathode temperature	950°C
Bias voltage	+150 ~ +300 V	Acceleration voltage	200 kV
Grid/cathode distance	180 µm	Gun pulse duration	4 µs
Beam duration	1 ns	Residual gas pressure	1 x 10 ⁻⁷ Pa
Beam time jitter	8 ps	ML magnetic field	~ 900 G

Design values of bunching system A

Prebuncher	Constant impedance	Drift space	42.27 mm
		Buncher	
Max. field	2.0 MV/m	field strength	15 MV/m
shunt impedance	14.97 MM/m	maxi. inpu power	13 Mw
group velocity/c	0.0494	cavity number	
attenuation	0.0597 Neper/m	buncher section	5 + coupler
coefficient		normal section	28 + coupler
maxi. Input power	2 MW	cavity size D	31.49~34.99 mm
cavity number	3 + couplers	2a	22.44~19.43 mm
cavity size D	24.318 mm	2b	82.53~81.75 mm
2a	36.89 mm		
2b	90.075 mm		

ダブルパルスの生成

Kenteckのパルサーを2台使用



パルサー(制御部)

Double pulse generation



2 grid pulsers & socket









2バンチの形状と電子・陽電子ビーム軌道

Close

First bunch



FWHM 15ps













Second bunch

KL-ATと電子銃高圧電源の共用化+降圧トランス


KL-ATと電子銃高圧電源の共用化+降圧トランス



KL_A1 モジュレータ内 PFN 架台裏に設置した

・GU_A1 高電圧波形立下り部をなます為、PFN ~ GU_A1 用ケーブル 間にコイルを取り付けた。 結果、GU_A1 高電圧波形はなまり、KLY 高電圧波形立下り後の歪みが改善された。

Pulse transformer and oil tank of gun A



Pulse transeformer & dumy load



Electron gun and collimator





Collimator holes $(2,4,6mm\phi)$



Relationship between Beam Emittance and Collimator Size



Diameter of Collimater or Beam (mm)

Relationship between Emittance and Beam Charge



Two-bunch beam generation for KEKB

- Two-bunch beams have been required to reduce injection times into KEKB rings.
- Especially for the LER it is being inevitable to increase positron ٠ intensity as the stored beam increases. Two-bunch beam acceleration is one of the methods to meet the requirement. In order to accelerate and accumulate the beams successfully, it is at least necessary to satisfy the following conditions: 1) each bunch length should be as short as the present single bunch, that is less than 10 ps, and 2) their time interval should be 97.29 ns that is a period of the common operation frequency between the linac and KEKB rings. Wake field effects are strong for high intensity beams. In normal acceleration sections beam energy of each bunch is thought to be controllable by means of changing acceleration timing with respect to RF pulses. In the bunching section, however, this technique is not useful. To obtain independent operation freedom we developed a system that produces a two-pulse beam from an electron gun each of which intensity and timing are independently changeable. Beam test results are presented as well as the system configuration and performance.



GRID PULSE TIMING FEED BACK MONITOR SYSTEM (2-BUNCH)



Magnetic lens and focusing coils















電子銃ビーム波形とバンチ形状







571MHz & induced fields

Correlation between beam position and gun-accelerating voltage



Two bunch beam orbit 1





Schematic layout of the pre-injector A



B8の加速管に誘起されたRFの位相を1度以内に押さえるには、各機器は 次の許容値以下でなければならない。この値は、対応するグラフの傾きから 求めたものである。*のビーム位置はSP-A1-1、他はSP-A4-4で測定した。

ビーム電荷	6nC	8nC	10nC
電子銃			
パルス電圧 (°/kV)		-	1.29
ビームジッター(°/mm)	-0.17	-0.11	-0.07
SHB1位相			
誘起波位相(゜/゜)	-0.94	-0.93	-0.57
軌道変位 x (mm/))	(0.12)*	-0.22	0.09
軌道変位 y (mm/°)	(0.30)*	0.14	0.12
SHB2位相			
誘起波位相(゜/゜)	-1.06	-0.64	-0.294
軌道変位 x (mm/°)		-0.11	-0.11
軌道変位 y(mm/°)		0.23	0.23
A 1 位相			
誘起波位相(゜/゜)		-	1.02
軌道変位 x (mm/゜)	<u>~</u>	<u> </u>	0.033
軌道変位 y (mm/°)			0.022

Orbits and Current in KEKB Linac & BT @10nC



positron production target

The 10-nC electron/positron beams accelerated in the KEKB linac

Tolerance for phases @ 10nC beam







The each tolerance range is defined so that when each instrument changes the transmission rate of the primary electron beam intensity maintains more than 90% of the maximum value at the positron production target.

Summary

Instruments	Tolerance range	Measurement accuracy	Stability*	Digital feed back
Gun beam timing	±45 ps	5 ps	20 ps	0
Gun high voltage	±0.38 %	0.02 %	< 0.1 %	0
SHB1 phase	±1.1 deg	0.05 deg	0.5 deg	-
SHB2 phase	±1.3 deg	0.2 deg	1.0 deg	-
Buncher phase	±1.7 deg	-	± 1.0 deg	-

* Long term stability of normal status.

• This system is doing on the reference of a Buncher entrance RF phase.

• Three kinds of RF phases that were directly associated to the electron beam are being measured directly with high accuracy.

•We are able to discover it right away if there is abnormality in these measurement data quantity.

•We aim for a more stable beam from now on, and be thinking digital feed back of SHB1/2 by using the measured value of this system.

Tolerance Measurement @1999/06/18







B8の加速管に誘起されたRFの位相を1度以内に押さえるには、各機器は 次の許容値以下でなければならない。この値は、対応するグラフの傾きから 求めたものである。*のビーム位置はSP-A1-1、他はSP-A4-4で測定した。

ビーム電荷	6nC	8nC	10nC
電子銃			
パルス電圧 (°/kV)	-	-	1.29
ビームジッター(゜/mm)	-0.17	-0.11	-0.07
SUB1件相			
5 H D I D I D I D I D I D I D I D I D I D	0.04	0.02	0.57
的起放世伯(7) 動道亦位 x (mm ²)	(0.12)*	-0.33	0.00
執道変位×(mm/) 動道変位×(mm/)	$(0.12)^{*}$ $(0.30)^{*}$	-0.22	0.09
· · · · · · · · · · · · · ·	(0.30)	0.14	0.12
5 H D Z 世 H	-1.06	-0.64	-0 294
前道変位 x (mm/°)	-1.00	-0.11	-0.11
前道変位 x (mm ^ℓ)		0.23	0.23
		0.25	0.25
新記波位相(°/°)	-	_	1.02
• 前道变位 x (mm/°)	_		0.033
軌道変位 y (mm/°)	-	-	0.022
灾储			
<u>ビーム電荷</u>	6nC	8nC	10nC
電子銃			
パルス電圧 (°/%)	-	-	2.6%
ビームジッター(ps/)	-39	-48	-95
SHB1位相			
誘起波位相(゜/゜)	-1.06	-1.08	-1.75
軌道変位 x (°/0.2mm)	(1.7)*	-0.91	2.2
軌道変位 y (°/0.2mm)	(0.67)*	1.4	1.7
SHB2位相			
誘起波位相(゜/゜)	-0.94	-1.6	-3.4
軌道変位 x (°/0.2mm)		-1.8	-1.8
軌道変位 y (°/0.2mm)		0.87	0.87
A 1 位相			
誘起波位相(°/°)	-	-	0.98
軌道変位 x (° /0.2mm)	worth-in	-	6.1
軌道変位 y (° /0.2mm)	-nl YF	PANT	9.1

A1 RF-phase dependence @10nC





SHB1 RF-phase dependence @8nC, June/14/1999





SHB1 RF-phase dependence @6nC





SHB1 RF-phase dependence @8nC



SHB2 RF-phase dependence @8nC



1.5

1.5

SHB2 RF-phase dependence @6, 8nC



Controller of the gun modulator A





Acceleration voltage	200 kV
Pulse width	4 μs
Pulse repetition rate	50 pps

Gun modulator circuit



Monitor and feedback systems of gun



1 GRID PULSE TIMING FEED BACK MONITOR SYSTEM (2-BUNCH)



2 SHB1/SHB2/BUNCHER RF Phase monitor system



Buncher & gun beam monitor system



2

4 Gun room temperature monitor system



History of Gun Room Temperature



- DMM 3478A
- \cdot 2001/03/23 00:00 \sim 2001/03/25 12:00

Gun HV measurement and feedback


PFN voltage change of the Gun pulser A



• DMM 34401A

· 2001/03/19 12:00 ~ 2001/03/24 13:00

PFN of gun modulators





Capacity 14.6 nF Section No. 3 x 5 Coil turn No. 10

Pulse transformer and oil tank of gun A



Pulse transeformer & dumy load



SHB1 of 114MHz





SHB2 of 571MHz



Quantities of Measurement

- Grid pulse amplitude and gun beam amplitude
- Grid pulse timing and gun beam timing
- Buncher beam timing vs. 2856MHz
- SHB1/SHB2/571MHz phase vs. 2856MHz
- Gun pulser E_{PFN} monitor output voltage
- Output signal for e⁺ pulse coil power supply
- Gun room temperature

Summary

Instruments	Tolerance range	Measurement accuracy	Stability*	Digital feed back
Gun beam timing	±45 ps	5 ps	20 ps	0
Gun high voltage	±0.38 %	0.02 %	0.1 %	0
SHB1 phase	±1.1 deg	0.05 deg	0.5 deg	-
SHB2 phase	±1.3 deg	0.2 deg	1.0 deg	-
Buncher phase	±1.7 deg	-	± 1.0 deg	-

* Long term stability of normal status.

• This system is doing on the reference of a Buncher entrance RF phase.

• Three kinds of RF phases that were directly associated to the electron beam are being measured directly with high accuracy.

•We are able to discover it right away if there is abnormality in these measurement data quantity.

•We aim for a more stable beam from now on, and be thinking digital feed back of SHB1/2 by using the measured value of this system.







Gun control panel 1



Gun control panels 2





Gun HV measurement

TD4 delay 2-ns step

Structure of the positron production target





History driving pulse for e+ Focusing Pulse Coil



 $2001/01/09 \ 11:00 \sim 2001/02/27 \ 21:00$

Two-bunch beam generation for KEKB

- Two-bunch beams have been required to reduce injection times into KEKB rings.
- Especially for the LER it is being inevitable to increase positron ٠ intensity as the stored beam increases. Two-bunch beam acceleration is one of the methods to meet the requirement. In order to accelerate and accumulate the beams successfully, it is at least necessary to satisfy the following conditions: 1) each bunch length should be as short as the present single bunch, that is less than 10 ps, and 2) their time interval should be 97.29 ns that is a period of the common operation frequency between the linac and KEKB rings. Wake field effects are strong for high intensity beams. In normal acceleration sections beam energy of each bunch is thought to be controllable by means of changing acceleration timing with respect to RF pulses. In the bunching section, however, this technique is not useful. To obtain independent operation freedom we developed a system that produces a two-pulse beam from an electron gun each of which intensity and timing are independently changeable. Beam test results are presented as well as the system configuration and performance.